

In re the Application of: **Hiroshi TANABE**

Filed: : **Concurrently herewith**

For : **METHOD FOR FORMING SEMICONDUCTOR FILMS AT DESIRED
POSITIONS ON A SUBSTRATE**

Serial No.: **Concurrently herewith**

July 12, 2000

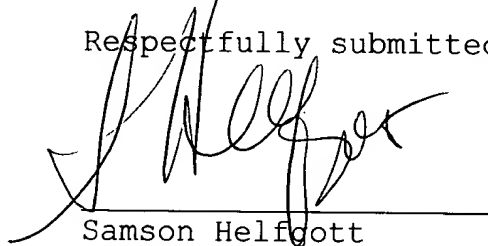
Assistant Commissioner of Patents
Washington, D.C. 20231

SUB-POWER OF ATTORNEY

S I R:

I, Samson Helfgott, Reg. No. 23,072 attorney of record
herein, do hereby grant a sub-power of attorney to Linda S.
Chan, Reg. No. 42,400, Jacqueline M. Steady, Reg. No., 44,354
and Harris A. Wolin, Reg. No. 39,432 to act and sign in my
behalf in the above-referenced application.

Respectfully submitted,



Samson Helfgott
Reg.No 23,072

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By: Lydia Gonzalez
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not covered by an enclosed check may be
charged on Deposit Acct. No. 08-1634.